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03/09/2006

FACSIMILE TRANSMISSION SHEET

TO: USPTO

(571) 273-8300

FROM: Sandip H. Patel

RE: U.S. Serial No. 10/730,295 (Atty. Docket No. 29936/39864)

PAGES (INCLUDING THIS PAGE): 3

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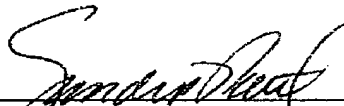
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PATENT

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant:	Kyeong Keun Choi	)	I hereby certify that this paper is being
Serial No.:	10/730,295	)	facsimile transmitted to the United States
Filed:	December 8, 2003	)	Patent and Trademark Office, Fax No.
Title:	METHOD FOR FORMING	)	(571) 273-8300, on
	HIGH RESISTIVE REGION	)	March 9, 2006.
	IN SEMICONDUCTOR	)	
	DEVICE	)	
Group Art Unit:	2813	)	
Examiner:	David S. Blum	)	
Attorney Docket No.:	29936/39864	)	

  
Sandip H. Patel (Reg. No. 43,848)  
Attorney for Applicant

PETITION TO WITHDRAW APPLICATION FROM ISSUE  
UNDER 37 CFR § 1.313(a) AND (c)(3)

Mail Stop Express Abandonment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

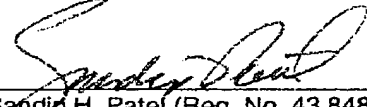
The applicant, through the undersigned attorney, hereby petitions to withdraw the above-identified application from issue pursuant to 37 CFR § 1.313(a) and (c)(3). The application was allowed December 23, 2005, and issue and publication fees were mailed February 1, 2006. A notice of express abandonment is submitted herewith.

The \$130.00 fee required under 37 CFR § 1.17(h) may be charged to Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN &amp; BORUN LLP

March 9, 2006

  
Sandip H. Patel (Reg. No. 43,848)  
Attorneys for Applicant  
6300 Sears Tower  
233 South Wacker Drive  
Chicago, Illinois 60606-6357  
Telephone: (312) 474-6300

03/13/2006 WABDEL1 00000050 132855 10730295

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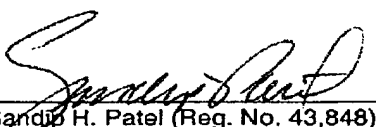
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MAR 09 2006

PATENT

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant:	Kyeong Keun Choi	)	I hereby certify that this paper is being
Serial No.:	10/730,295	)	facsimile transmitted to the United States
Filed:	December 8, 2003	)	Patent and Trademark Office, Fax No.
		)	(571) 273-8300, on <b>March 9, 2006</b> .
Title:	METHOD FOR FORMING HIGH RESISTIVE REGION IN SEMICONDUCTOR DEVICE	)	
Group Art Unit:	2813	)	
Examiner:	David S. Blum	)	
Attorney Docket No.:	29936/39864	)	

  
Sandip H. Patel (Reg. No. 43,848)  
Attorney for Applicant

## NOTICE OF EXPRESS ABANDONMENT

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

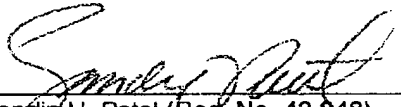
This paper accompanies a petition under 37 CFR § 1.313(a) and (c)(3) to withdraw the above-identified application from issue.

The applicant, through the undersigned attorney, expressly abandons the above-identified application upon granting the accompanying petition.

Respectfully submitted,

MARSHALL, GERSTEIN &amp; BORUN LLP

March 9, 2006

  
Sandip H. Patel (Reg. No. 43,848)  
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